

L Number	Hits	Search Text	DB	Time stamp
1	17490	700/\$.ccls.	USPAT	2002/11/29 17:45
2	6361	700/\$.ccls. and sensor	USPAT	2002/11/29 17:46
3	40	(700/\$.ccls. and sensor) and turbidity	USPAT	2002/11/29 17:46
4	0	((700/\$.ccls. and sensor) and turbidity) and "chemical mechanical polishing"	USPAT	2002/11/29 17:47
5	0	((700/\$.ccls. and sensor) and turbidity) and cmp	USPAT	2002/11/29 17:47
6	1	((700/\$.ccls. and sensor) and turbidity) and wafer	USPAT	2002/11/29 17:47